PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT4569789

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE

CONVEYING PARTY DATA

Name	Execution Date
MASSACHUSETTS INSTITUTE OF TECHNOLOGY	08/22/2017

RECEIVING PARTY DATA

Name:	National Institutes of Health (NIH), U.S. Dept. of Health and Human Services (DHHS), U.S. Government
Street Address:	NIH Division of Extramural Inventions and Technology Resources (DEITR)
Internal Address:	6705 Rockledge Drive, Suite 310, MSC 7980
City:	Bethesda
State/Country:	MARYLAND
Postal Code:	20892-7980

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14435057

CORRESPONDENCE DATA

Fax Number: (301)480-0272

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Email: edison@nih.gov
Correspondent Name: DIRECTOR, DEITR

Address Line 1: NIH, 6705 ROCKLEDGE DRIVE, SUITE 310

Address Line 2: MSC 7980

Address Line 4: BETHESDA, MARYLAND 20892-7980

NAME OF SUBMITTER:DIRECTOR, DEITR, NIHSIGNATURE:/Director, DEITR, NIH/DATE SIGNED:08/29/2017

Total Attachments: 1

source=4911501-14435057#page1.tif

PATENT 504523083 REEL: 043702 FRAME: 0796

License to the United States Government

RECORDED: 08/29/2017

Sign and submit the executed document to the appropriate funding agency (e.g. upload in iEdison).
nvention Title: Polymer Base-Layer for Rapid Delamination of Multi-Layer Films From
Microneedles
nventor(s): Paula T Hammond-Cunningham, Peter Charles DeMuth, Younjin Min, Darrell J Irvine
J.S. Filing/Issue Date: 04/10/2015
Patent or Application Serial No.: 14/435, 057
Grant/Contract Number(s): R01 AI095109, W911NF-07-D-0004
Foreign Applications filed/intended in (countries):
The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq. , and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above dentified grant or contract award from the United States Government. This document is confirmatory of:
The nonexclusive, nontransferable, irrevocable, paid-up license to practice or have practiced for or on behalf of the United States the invention described in any patent application and in any and all divisions, continuations, and continuations in part, and in any and all patents and re-issues granted thereon throughout the world; and All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations that are applicable to the award.
The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified paten application.
Signed this 22ndday ofAugust, 2017
By Kevin McCaffrey
(Institutional Business Official) (Signature)
Fitle Patent Compliance Administrator
For MASSACHUSETTS INSTITUTE OF TECHNOLOGY
(Grantee/Contractor Organization)
At 255 Main Street NE18-501 Cambridge, MA 02142 (Business Address)
(many company company)

PATENT REEL: 043702 FRAME: 0797